

PATENT APPLICATION

IN THE UNITED STATES PATENT AND TRADEMARK OFFICE

In re the Application of

Takeshi KIJIMA et al.

Group Art Unit: 1775

Application No.: 10/690,021

Examiner: L. XU

Filed: October 22, 2003

Docket No.: 117581

For: FERROELECTRIC FILM, FERROELECTRIC CAPACITOR AND METHOD OF
FABRICATING THE SAME, FERROELECTRIC MEMORY, PIEZOELECTRIC
ELEMENT AND SEMICONDUCTOR

INFORMATION DISCLOSURE STATEMENT

Commissioner for Patents
P.O. Box 1450
Alexandria, VA 22313-1450

Sir:

Pursuant to 37 CFR §1.56, the attention of the Patent and Trademark Office is hereby directed to the reference(s) listed on the attached PTO-1449. Unless otherwise indicated herein, one copy of each reference is attached. It is respectfully requested that the information be expressly considered during the prosecution of this application, and that the reference(s) be made of record therein and appear among the "References Cited" on any patent to issue therefrom.

- ☒ 1. This Information Disclosure Statement is being filed with a Request for Continued Examination. No certification or fee is required.
- ☒ 2. One or more reference cited herein was cited in a related foreign application. See References 3 and 4.
- ☒ 3. In accordance with 37 CFR §1.98(a)(2)(ii), copies of any U.S. patents and patent application publications are not attached.
- ☒ 4. An English language Abstract of one or more non-English language reference is attached hereto. See Reference 4.

- ☒ 5. References 1 and 2 correspond to references 3 and 4, respectively.

Respectfully submitted,

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<p>DEPOSIT ACCOUNT USE AUTHORIZATION Please grant any extension necessary for entry; Charge any fee due to our Deposit Account No. 15-0461</p>
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Form PTO-1449 (REV. 1/06)		US Dept. of Commerce PATENT & TRADEMARK OFFICE		ATTY DOCKET NO. 117581		APPLICATION NO. 10/690,021	
INFORMATION DISCLOSURE STATEMENT (Use several sheets if necessary)				APPLICANT(S) Takeshi KIJIMA et al. FILING DATE October 22, 2003			
U.S. PATENT DOCUMENTS							
Examiner Initials	Cite No.	Document Number	Date	Name			
	1	6,624,462	9/23/03	KOHARA et al.			
	2	2004/0136891	7/15/04	KIJIMA et al.			
FOREIGN PATENT DOCUMENTS							
Examiner Initials	Cite No.	Document Number	Date	Country	With English Abstract	With English Translation	
	3	EP 1 078 998	2/28/01	EUROPE			
	4	WO 02/32809	4/25/02	WIPO	x		
OTHER DOCUMENTS							
Examiner Initials	Cite No.	(Including Author, Title, Date, Pertinent Pages, etc.)					
EXAMINER					DATE CONSIDERED		
Examiner: Initial if citation considered, whether or not citation is in conformance with M.P.E.P. 609; draw line through citation if not in conformance and not considered. Include copy of this form with next communication to applicant.							

Date: October 3, 2006